

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of
Izumi FUSEGAWA et al.

#3

Application No.: 10/510,695

Filed: October 8, 2004

Docket No.: 121356

For: METHOD OF MANUFACTURING SILICON SINGLE CRYSTAL, SILICON SINGLE CRYSTAL AND SILICON WAFER

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Relevance of non-English language References 1 and 5 is discussed in the present specification.
- ☒ 3. References 1-4 were cited in the International Search Report. An English language version of the International Search Report is attached for the Examiner's information.
- ☒ 4. English language Abstracts of the non-English language references are attached hereto.
- ☒ 5. Computer-generated English language translations of the following Japanese references have been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and are attached, but have not been reviewed for accuracy. See References 1-3.

Respectfully submitted,



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<p>DEPOSIT ACCOUNT USE AUTHORIZATION</p> <p>Please grant any extension necessary for entry;</p> <p>Charge any fee due to our Deposit Account No. 15-0461</p>
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Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 121356		APPLICATION NO. 10/510,695	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANTS Izumi FUSEGAWA et al.			
				FILING DATE October 8, 2004			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
	1.	JP-A-09-165298 w/ abst. & trans.	06/24/1997	JAPAN			
	2.	JP-A-10-203898 w/ abst. & trans.	08/04/1998	JAPAN			
	3.	JP-A-10-324594 w/ abst. & trans.	12/08/1998	JAPAN			
	4.	JP-A-01-203287 w/ abst.	08/16/1989	JAPAN			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
	5.	Nikkei Microdevices; No. 188; February, 2001; pp. 64-69; Nikkei BP Inc.					
EXAMINER				DATE CONSIDERED			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: December 7, 2004